

In re: Chung et al.  
Serial No.: 10/823,352  
Filed: April 13, 2004  
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Best Available Copy

In the Title:

Please amend the title as follows:

METHODS OF FORMING CAPACITORS OF SEMICONDUCTOR DEVICES  
INCLUDING SILICON-GERMANIUM AND METALLIC ELECTRODES ~~AND~~  
~~METHODS OF FABRICATING THE SAME.~~